IAP20 Roc'd PCT/PTO 15 DEC 2005

S/N

unknown

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

HASHIMOTO et al.

Examiner:

unknown

Serial No.:

Unknown

Group Art Unit:

Unknown

Filed:

Concurrent herewith

Docket:

10873.1782USWO

Title:

COMPOUND SEMICONDUCTOR FILM, SOLAR CELL,

AND PRODUCTION THEREOF

CERTIFICATE UNDER 37 CFR 1.10

Express Mail mailing label number: EV 775296127 US

Date of Deposit: DECEMBER 15, 2005

I hereby certify that the papers listed below are being deposited with the United States Postal Service Express Mail Post Office to Addressee service under 37 CFR 1.10 in an envelope addressed to: Mail Stop PCT, Commissioner for Patents, P.O. Box 1450, Arlington, VA 22313-1450.

Name: RALYNN WILHELM

INFORMATION DISCLOSURE STATEMENT (37 C.F.R. § 1.97(c))

MS PCT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

With regard to the above-identified application, the items of information listed on the enclosed Form 1449 are brought to the attention of the Examiner. At least some of the references were recently cited in an International Search Report, mailed February 22, 2005.

This statement should be considered because it is submitted within three months of the filing date of the above-identified application, which is not an application under 37 C.F.R. §1.53(d). Accordingly, no fee is due for consideration of the items listed on the enclosed Form 1449.

In accordance with 37 C.F.R. §1.98(a)(2), a copy of each non-U.S. document or other information listed on the enclosed Form 1449 is provided. A copy of the

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International Search Report is enclosed. Applicants believe that the references from the ISR are available to the Examiner and therefore are not supplying copies.

No representation is made that a reference is "prior art" within the meaning of 35 U.S.C. §§ 102 and 103 and Applicants reserve the right, pursuant to 37 C.F.R. § 1.131 or otherwise, to establish that the reference(s) are not "prior art." Moreover, Applicants do not represent that a reference has been thoroughly reviewed or that any relevance of any portion of a reference is intended.

Consideration of the items listed is respectfully requested. Pursuant to the provisions of M.P.E.P. 609, it is requested that the Examiner return a copy of the attached Form 1449, marked as being considered and initialed by the Examiner, to the undersigned with the next official communication.

Respectfully submitted,

HAMRE, SCHUMANN, MUELLER &

LARSON, P.C. P.O. Box 2902

Minneapolis, MN 55402-0902 (612) 455-3800

glas P. Mueller

Reg. No. 30,300

DPM:nel

Dated: December 15, 2005

IAP20 ROC'd PCT/PTO 15 DEC 2005

Date Mailed: DECEMBER 15, 2005

Sheet 1 of 1

FORM 1449*

INFORMATION DISCLOSURE STATEMENT

Docket Number: 10873.1782USWO

Application Number:

IN AN APPLICATION
(Use several sheets if necessary)

Applicant: HASHIMOTO et al.

Filing Date: CONCURRENT HEREWITH

Group Art Unit: UNKNOWN

		U	S. PATENT DOCUMEN	TS	·		
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	6,259,016	7.10.2001	NEGAMI et al.			,	
	<u></u>	FOR	EIGN PATENT DOCUM	IENTS	<u>l</u>	<u> </u>	
, ,	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
	2000-332273	11.30.2000	JAPAN			ABSTRACT AND PARTIAL	
	11-026789	1.29.1999	JAPAN			ABSTRACT AND PARTIAL	
	3249342	11.9.2001	JAPAN			ABSTRACT	
	OTHER	DOCUMENTS	(Including Author, Title,	Date, Pertinent I	Pages, Etc.)		
	Film Sola		"Application of Zn-Comp Appl. Phys. Vol. 35 (1996)				
	C.H. HUA Materials	ANG et al., "Stuc & Solar Cells, V	ly of Cd-free buffer layers ol. 69, 2001, pp. 131-137 (using In _x (OH,S) (identified in the	y on CIGS solar ce ISR)	ells", Solar Energy	,
			ar-beam Epitaxy-grown Zn 2001, pp. 1811-1813 (ider			pplied Physics Le	tters,

53148
PATENT TRADEMARK OFFICE

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.